



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## BIB DATA SHEET

CONFIRMATION NO. 8901

<b>SERIAL NUMBER</b> 10/599,440	<b>FILING or 371(c) DATE</b> 09/28/2006 <b>RULE</b>	<b>CLASS</b> 510	<b>GROUP ART UNIT</b> 1716	<b>ATTORNEY DOCKET NO.</b> 09852/0205523-US0		
<b>APPLICANTS</b> Hideki Fujiwara, Tokyo, JAPAN; Kazuhiro Ikezawa, Tokyo, JAPAN; Hiroaki Taguchi, Tokyo, JAPAN; Naofumi Iwamoto, Takarazuki-shi, JAPAN; Toshinori Ishii, Osaka, JAPAN; Takashi Komekyu, Sanda-shi, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/06134 03/30/2005 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-108731 04/01/2004 JAPAN 2004-234961 08/12/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 04/27/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/ANNA M CROWELL/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 1	<b>TOTAL CLAIMS</b> 1	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> Leason Ellis LLP 81 Main Street Suite 503 White Plains, NY 10601 UNITED STATES						
<b>TITLE</b> Silicon electrode plate for plasma etching with superior durability						
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			